

WEST**Freeform Search****Database:**

US Pre-Grant Publication Full-Text Database
 JPO Abstracts Database
 EPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Term:

Display: Documents in Display Format: Starting with Number
Generate: ☐ Hit List ☒ Hit Count ☐ Side by Side ☐ Image

Search

Clear

Help

Logout

Interrupt

Main Menu

Show S Numbers

Edit S Numbers

Preferences

Cases

Search HistoryDATE: Monday, September 23, 2002 [Printable Copy](#) [Create Case](#)

Set Name Query
 side by side

Hit Count Set Name
 result set

DB USPT:PIUR YLS OP OR

((gate NEAR insulat\$4) NEAR3 (semiconductor) NEAR3 ("data
 wire" OR "data line" OR "signal wire" OR "signal line")) same
 (("single photolithography" OR "same photolithography"))

0 1.1

END OF SEARCH HISTORY

WEST

Help

Logout

Interrupt

Main Menu

Search Form

Posting Counts

Show S Numbers

Edit S Numbers

Preferences

Cases

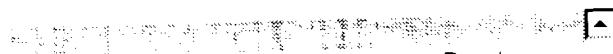
Search Results -

Terms

Documents

("pixel" near electro\$d\$3) near3 ((on color" near filter\$2) or ("over color" near filer\$3))

0



US Pre-Grant Publication Full-Text Database

JPO Abstracts Database

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Derwent World Patents Index

Database: IBM Technical Disclosure Bulletins

Search:

1.3



Refine Search



Recall Text



Clear

Search History

DATE: Monday, September 23, 2002 Printable Copy Create Case

Set Name Query

side by side

Hit Count Set Name
result set

DB USPL PLUR YLS OP OR

L3

("pixel" near electro\$d\$3) near3 ((on color" near filter\$2) or ("over color" near filer\$3))

0

L3

L2

(pixel near electro\$d\$3) near3 ((on color filter\$2) or (over color filer\$3))

876

L2

L1

((gate NEAR insulat\$4) NEAR3 (semiconductor) NEAR3 ("data wire" OR "data line" OR "signal wire" OR "signal line")) same ("single photolithography" OR "same photolithography"))

0

L1

END OF SEARCH HISTORY